



06/29/04

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Docket No. 7956/DISPLAY/AHRDWR/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Re: Inventor(s): Shinichi Kurita, Emanuel Beer, Edgar Kehrberg and Matthias Brunner  
Title: METHODS AND APPARATUS FOR DETERMINING A POSITION OF A SUBSTRATE RELATIVE TO A SUPPORT STAGE  
Serial No.: 10/782,503  
Filed: February 19, 2004

Transmitted herewith is:

☒ PTO Form 1449 and Information Disclosure Statement with five cited references.

☒ Return Postcards

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	N/A	- 20 =	-0-	X \$18.00	\$0.00
Independent Claims	N/A	- 3 =	-0-	X \$84.00	\$0.00
Basic Filing Fee				\$740.00	\$0.00
TOTAL FEES					\$0.00

☐ The Commissioner is hereby authorized to charge \$0.00 to Deposit Account No. 04-1696.

☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 04-1696. A duplicate copy of this transmittal is enclosed.

☒ Please address all future correspondence to:  
**Customer # 41161**  
**Dugan & Dugan, PC**  
**55 South Broadway**  
**Tarrytown, NY 10591**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to:  
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Date of Deposit: 6/28/04

Signature: [Signature]

Respectfully submitted,

[Signature]  
Brian M. Dugan  
Registration No. 41,720  
(914) 332-9081



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PATENTS  
7956/DISPLAY/AHRDWR/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Shinichi Kurita, Emanuel Beer, Edgar  
Kehrberg and Matthias Brunner

Serial No. : 10/782,503

Filed : February 19, 2004

For : METHODS AND APPARATUS FOR DETERMINING A  
POSITION OF A SUBSTRATE RELATIVE TO A  
SUPPORT STAGE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97,  
applicants wish to call the attention of the Examiner to the  
following references:

U.S. Patent No. 6,327,034 B1, Hoover et al.

U.S. Patent No. 4,628,238, Smulders et al.

Foreign Art Reference No. EP 1 067 589 A2 (EPO)

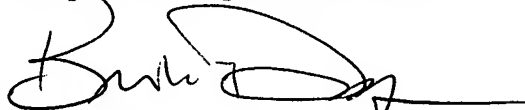
Foreign Art Reference No. JP 04149917 (Japan)

Foreign Art Reference No. JP 2001358202 (Japan)

These references are also listed on the accompanying  
Information Disclosure Statement (Form PTO-1449).

Consideration of the foregoing in relation to this  
patent application is respectfully requested.

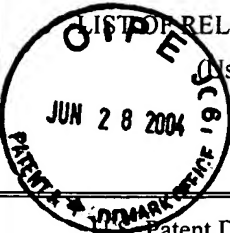
Respectfully Submitted,

A handwritten signature in black ink, appearing to read 'Brian M. Dugan', with a long horizontal flourish extending to the right.

Brian M. Dugan, Esq.  
Registration No. 41,720  
Dugan & Dugan, PC  
Attorneys for Applicants  
(914) 332-9081

Dated:

6/28/04  
Tarrytown, New York

U.S. Department of Commerce, Patent and Trademark Office  <div style="text-align: center;">  </div>				Docket No.: 7956/DISPLAY/AHRDWR/RKK		Serial No.: 10/782,503	
LIST OF RELEVANT ART CITED BY APPLICANT (Use several sheets if necessary)				Applicants: Shinichi Kurita, et al			
				Filing Date: February 19, 2004		Group:	

U.S. Patent Documents							
*Examiner Initial	Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate	
	US-1	6,327,034 B1	12/04/01	Hoover et al.			
	US-2	4,628,238	12/09/86	Smulders et al.			
	US-3						
	US-4						
	US-5						
	US-6						
	US-7						
	US-8						
	US-9						
	US-10						
	US-11						

Foreign Patent Documents							Translation	
	Document Number	Date	Country	Class	Subclass	Yes	No	
	F-1	EP 1 067 589 A2	01/10/01	EPO				
	F-2	JP 04149917	05/22/92	Japan		X abstract only		
	F-3	JP 2001358202	12/26/01	Japan		X abstract only		
	F-4							
	F-5							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)	
OT-1	
OT-2	
OT-3	

Examiner	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.